제20회 한국반도체학술대회

2013년 2월 4일(월)~6일(수) / 웰리힐리파크 (구, 성우리조트)

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C. Materials Growth & Characterization 분과

Room D

스카이홀 (본관, 2층)

2013년 2월 6일(수) 15:10-16:25 [WD3-C] Graphene and Characterization

좌장: 권순용(울산과학기술대학교), 송진동(KIST)

WD3-C-1 15:10-15:25 CVD를 이용한 그래핀의 전자기 차폐효과

홍슬기, 김기영, 김택용, 김정호, 조병진

KAIST 전기 및 전자공학과

WD3-C-2 15:25-15:40 Properties of Graphene Fabricated using Pulsed Laser Graphitization

of Si-face 4H-SiC Substrate

조천흠¹, 임성관¹, 황현준², 강창구², 이영곤², 신희성¹, 최호준², 황현상³,

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WD3-C-3 15:40-15:55 Low-Temperature Synthesis of Graphene Films on Nonconducting

Surfaces

Jinsung Kwak¹, Jae Hwan Chu¹, Jae-Kyung Choi¹, Soon-Dong Park¹, Heungseok Go², Sung Youb Kim¹, Kibog Park², Sung-Dae Kim³, Young-Woon Kim³, Euijoon Yoon³, Suneel Kodambaka⁴, and Soon-Yong Kwon^{1,2} ¹School of Mechanical and Advanced Materials Engineering, Ulsan National Institute of Science and Technology, ²School of Electrical and Computer Engineering, Ulsan National Institute of Science and Technology, ³Department of Materials Science and Engineering, Seoul National University, ⁴Department of Materials Science and Engineering,

University of California Los Angeles

WD3-C-4 15:55-16:10 One-Step Gallium Nitride on Sapphire Through Graphene Coating

> Jae-Kyung Choi¹, Jae-Hoon Huh¹, Sung-Dae Kim², Daeyoung Moon², Duhee Yoon³, Ki Su Joo², Jinsung Kwak¹, Jae Hwan Chu¹, Sung Youb Kim^{1,4}, Kibog Park^{4,5}, Young-Woon Kim², Euijoon Yoon², Hyeonsik

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